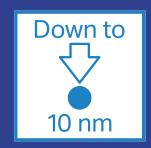
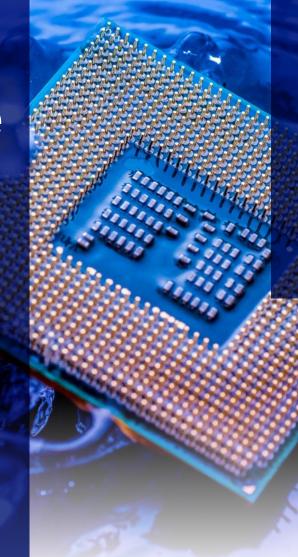


Meet Tomorrow's Challenges with Nanoscale Expertise

Particle and Environmental Monitoring Products for Electronics and Semiconductor



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Meet Tomorrow's Challenges with Nanoscale Expertise

Environmental Monitoring Products for Electronics and Semiconductor

Airborne Particle Counters

10 nm to 25 µm measurement

Models for every electronics and semiconductor environment and application including:

- Cleanroom monitoring
- Tool monitoring
- Gas monitoring

Nano LPM™ System

- Ensures reliable nanoparticle detection down to 10 nm in UPW
- Ultralow false counts
- Onboard tablet interface for modern, multi-functional data analysis

AeroTrak™+ Remote Particle Counters Ultra-Reliable Data Collection

- Protect against network failures with six months of data storage
- Flexible environmental monitoring system with Wi-Fi® communication

Aerosol Sampling Manifold

- Monitor up to 32 points with a single particle counter
- **High Pressure Diffusers**
 - Measure particulate contamination in high-pressure compressed gas systems

AeroTrak™+ Portable Particle Counters

- Different sample modes for monitoring, classifying, and root cause investigation
- Built-in monitoring and classification reports
- **AeroTrak™ Handheld Particle Counters**
- **Integrated Environmental Monitoring Probes**
 - Using FMS

AeroTrak™ Cleanroom Condensation Particle Counter

- Confident 24/7 operation
- Minimal maintenance
- High flow rates
- Ultra-low false count rates
- No contamination or chemicals introduced into the ultra-clean environment

TSI[®] Facility Monitoring Software: **Reliable Monitoring Systems**

Distributed. Flexible. Redundant.

- No single point of failure
- Data available where and when you need it
- Easily scalable





FMS Architecture





Monitor: Data Collection

- Fault-tolerant design
- Protects against network failures
- Hot-standby options

Client: Interface

- Turn data into knowledge with alarming, reports, and trending
- Does not effect monitor or database functions
- Access anywhere with FMS Web Client

Database: Secure Storage

- Valuable data is safe and secure
- Redundancy is standard with a mirror database
- SQL for high availability and fast access



Gas Monitoring

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Particle and Environmental Monitoring Products for Electronics and Semiconductor

Facility Monitoring System

A reliable monitoring system that supports process control and decreases downtime.

Minimum Particle Size Benefits and Features

Remote Particle Counters

Designed for continuous monitoring as part of the Facility Monitoring System with Analog and WiFi options

0.1 CFM (2.83 LPM) flow rate, includes AeroTrak™+ 6000 series 0.2 μm onboard pump, compact size, many communications options

0.1 CFM (2.83 LPM) and 1 CFM (28.3 AeroTrak™+ 7000 series 0.2 um LPM) flow rate, compact size, many

communications options

1 CFM (28.3 LPM) flow rate, internal pump, 0.3 to 5.0 channels available, field-removable AeroTrak™+ 6310 0.3 um

1 CFM (28.3 LPM) flow rate, complies AeroTrak™ 7110 0.1 um (100 nm) with all ISO 21501-4 requirements

Portable Particle Counters

AeroTrak™+ A100 Series 0.3 μm

Versatile instruments suitable for classification and monitoring

1 CFM (28.3 LPM), 1.77 CFM (50 LPM),

and 3.53 CFM (100 LPM) flow rate models available, intuitive interface, simplifies sampling with workflows, built-in classification and monitoring reporting capabilities, gas

and filter testing

1 CFM (28.3 LPM) flow rate, includes display and onboard pump, provides classification testing, complies with all ISO 21501-4 AeroTrak™ 9110 0.1 µm (100 nm)

Handheld Particle Counters

Economical choice for higher class cleanrooms and investigations

0.1 CFM (2.83 LPM) flow rate, 3 channels AeroTrak™ 9303 of simultaneous data, small, lightweight,

versatile, low cost

0.1 CFM (2.83 LPM) flow rate, 6 channels AeroTrak™ 9306 0.3 um of simultaneous data, versatile

Cleanroom Condensation Particle CounterThe only water-based, laminar flow CPC on the market that can run continuously, 24/7,

or as a standalone unit

Nano LPM™ System

AeroTrak Cleanroom 0.1 CFM (2.83 LPM) flow rate, ultralow zero 0.01 µm (10 nm)

CPC 9001

Nanoparticle Monitoring in Ultrapure Water (10 nm)
Empowers data-driven decisions in UPW monitoring...like never before.

0.01 um (10 nm)

Enables proactive, data-driven action before product quality is affected — ensuring reliable detection down to 10 nm, ultralow false counts for state-of-the-art semiconductor and electronics UPW systems, onboard tablet interface for modern, multi-functional data analysis

counts for cleanroom processes



TSI Incorporated - Visit our website www.tsi.com for more information.

USA Tel: +1 800 874 2811 India Tel: +91 80 67877200 UK Tel: +44 149 4 459200 Tel: +86 10 8219 7688 China Tel: +33 1 41 19 21 99 Tel: +65 6595 6388 France Singapore Tel: +49 241 523030

E Down to 10 nm

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